

DOCKET NO.: 240882US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF :
TOMOHISA KONNO ET AL : EXAMINER: RACHUBA, MAURINA T.
SERIAL NO.: 10/626,521 :
FILED: JULY 25, 2003 : GROUP ART UNIT: 3723
FOR: AQUEOUS DISPERSION FOR :
CHEMICAL MECHANICAL POLISHING :
AND PRODUCTION PROCESS OF :
SEMICONDUCTOR DEVICE :
"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 3223"

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 6, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.